

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/628,256	CHEN, TAILEE
Examiner Shih-Chao Chen	Art Unit 2821	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
343	700MS	2/2/2005	CHEN
343	795	2/2/2005	CHEN